





## Nano-scale Imaging & Surface Analysis

(co-located MRSEC shared facilities)

- JEOL JEM-2800 S/TEM with ultrafast EDS (3D tomo)
  Protochips liq & gas phase ETEM / electrochemistry
- FEI Helios Nanolab 650i hi-res dbFIB, Nabity EBL
  Pt, W, C dep; XeF<sub>2</sub>, I<sub>2</sub>, H<sub>2</sub>O enhanced etch, EDS, EBSD
- FEI Quanta 600 FE-ESEM w/ EDS, EBSD, particle ID, MAPS
- Kratos AxisUltra imaging XPS / Auger / ISS / UPS
- EDAX Eagle III Microspot XRF (μprobe & mapping)
- JEOL 5910 LV-SEM (quick-look inspection SEM)
- Bruker ICON-PT AFM: PF-QNM, wet cell, MFM, KPFM
- Woollam V-VASE spectroscopic ellipsometer
- ZYGO NewView 5032 optical profilometer
- Micro fiducial laser cutter for correlative multiscale microscopy: 355, 532, 1064 nm; 1.2-15mJ
- Vertex 220 microVu Digital Comparator
- SEM/TEM prep tool suite, manual and ion polishing
- Hysitron TI Premier Nanoindenter system

### Cleanroom

### **DESIGN & SIMULATION SOFTWARE**

- L-Edit, Cadence, AutoCAD
- Link-CAD DXF/GDSII/CIF/PG/EM conversion tools
- SASS JMP statistical design of experiments (CADE)
- ANSYS & COMSOL finite element analysis

## LITHOGRAPHY (C-100) Pattern Generation & Transfer

- Heidelberg μPG 101 Laser Pattern Generator (x2)
  0.9μm, 2.5μm write heads, gray scale patterning
- Nanofrazor 20-50nm nanolitho tool (pending 8/17)
- EVG EV-420, Suss MA1006 front & backside mask aligner
- OAI Models 200 & 810 (with BSA) contact aligners
- Spinners, ovens, hot plates, hoods, SRDs, ...
- LOR 7B, AZ 9620, Shipley 1813, nLOF 2020
- YES HMDS vapor prime vacuum ovens

## **THIN FILM DEPOSITION (C-1000)** Sputtering:

- TMV SS-40C: 8 dedicated cathodes, dual cryo-pumped
- Denton Discovery 18: 3 user config 3" cathodes, RF/DC
- Denton 635LL: 4-cat, RGA, OES-feedback reactive sputter Metals/Alloys: Ag, Al, Al/Si, Au, C, Chromel, Co, Cr, Cu, Cu/Ag, Ir, Ge, Fe, Ni, NiCr, NiCrFe, Nb, Pd, Pt, Si (p-type), Ta, Ti, TiW, V, W, Cr<sub>2</sub>Si, Zr, Hf

Oxides / Ceramics: Al<sub>2</sub>O<sub>3</sub>, SiO<sub>2</sub>, ITO, BN, CeSm(ox), LaSrFe(ox), NaMnO<sub>3</sub>, NdMgO, SiC, Si<sub>3</sub>N<sub>4</sub>, TaO<sub>2</sub>, TiO<sub>2</sub>, YNiZrO, YSZ, ZnO, MgO

Evaporation: Al, Ag, Au, Au/Ge, Cr, Cu, In, Mg, Mo, NiCr, Ni, Ta, Ti

- Denton e-beam DV-SJ/20C with 4 hearths, user config
- CHA 600 e-beam (AI, Mq)

#### **PECVD**

Oxford Plasmalab 80+: α-Si, Si<sub>3</sub>N<sub>4</sub>, SiON<sub>x</sub>, SiO<sub>2</sub>

### CVD

◆ SCS PDS 2010 Parylene-C

#### ALD

Cambridge Fiji F200 w/ thermal & plasma dep modes, H<sub>2</sub>O plasma (Pt, HfO<sub>2</sub>, ZnO, Al<sub>2</sub>O<sub>3</sub>, SiO<sub>2</sub>, TiO<sub>2</sub>, MgO, ZrO<sub>2</sub>, AlN)

## FURNACES and DIFFUSION (C-1000) LPCVD

• Expertech TEOS / LTO / PSG / low-stress Si<sub>3</sub>N<sub>4</sub>, α & phos-polySi

## Atmospheric and Rapid Annealing

- ◆ Blue-M box furnace with N₂ purge
- ProTemp wet/dry oxidation with DCE
- Allwin 610 RTP/RTA with O<sub>2</sub>, N<sub>2</sub>, Ar, H<sub>2</sub> forming gas, 200-1250C
- Tystar MiniTitan 4600 clean oxidation (pending installation)

# ETCH (C-1000)

### **RIE and DRIE**

- STS Aspect ICP DRIE: time-multiplex Si etch (anti-footing)
- Oxford Plasmalab 100+ ICP time-multiplex & cryo DRIE SF<sub>6</sub>, CF<sub>4</sub>, CHF<sub>3</sub>, O<sub>2</sub>, Ar, N<sub>2</sub>
- Oxford Plasmalab 80+ multipurpose (SF<sub>6</sub>, CF<sub>4</sub>, O<sub>2</sub>, Ar)
- ◆ Technics PEII H<sub>2</sub>O, O<sub>2</sub> descum & resist strip
- ◆ Xactix Xetch XeF<sub>2</sub> silicon isotropic etch
- Plasmatherm 790 (2X, oxide and metal etch Cl<sub>2</sub>, BCl<sub>3</sub> pending)

### Wet Chemical

- Bold & WAFAB wet benches (x6) acids, bases, organics
- Au etch station

## MICROMACHINING

- JPSA Micromachining system Ar/F<sub>2</sub> 193 nm
- Reel-Tech LM4000 Nd-YAG (1064nm) laser micromachining
- Custom KOH bulk Si etch station
- Cu & Ni electroplating station

## **BACKEND PROCESSES & PACKAGING**

- Strasbaugh 6EC 100 mm CMP (Si, SiO2 polishing & planarizing)
- EVG 520IS wafer bonder (hot embossing, thermal & anodic)
- Disco DAD 641 & Disco 3220 dicing saws (std or UV tape)
- MEI wedge wirebonder with Au and Al wire
- TUI 9101 wire bond pull tester

## **MESO-SCALE PROTOTYPING**

- LaserStar 1900 micro laser welder (1064nm, 150J)
- Viteris Technologies Precision Microwire EDM
- CO<sub>2</sub> Laser (dual laser cartridge, 25W + 75W, 1090nm)







### CLEAN (class 10k) MICROFLUIDICS

- Omnicure 1000 UV curing (320-500nm)
- lamination press
- ◆ Corona discharge UV/O<sub>3</sub> plasma treatment
- Fume hood with CEE Spinner Vacuum Oven Suite

#### CLEANROOM (C-1000) METROLOGY

- Keyence VHX-5000 3D microscope
- ◆ LEO 440 SEM
- n&k NKT 1500 thin film analyzer
- Nanometrics NanoSpec 3000 film thickness
- Magnetron Instruments 4-point probe
- Polyvar Met with DIC + many optical microscopes
- Nikon V12A optical comparator
- Tencor P-10 and P-20 stylus profilometers
- Tencor Flexus 2320 film stress analyzer

#### **ELECTRICAL / MAGNETIC TESTING**

- Verigy 9300 SOC IC tester
- Microsense vibrating sample magnetometer (EZ-7 VSM)
- Keysight 404A Mixed Signal O-scope
- Keysight E5061B Network Analyzer
- Keithley 4200 parameter analyzer with 4 SMUs
- Micromanipulator light-tight probe station

## STAFF SERVICES

- Equipment Installation, Diagnostics, and Repair
  - Alcatel ASM 180TD dry-pumped leak detector
- Professional Technical Support
  - Design of Experiments (DOE)
  - o R&D Process Development
- Thin Film Deposition and Patterning
- Center for Engineering Innovation www.cei.utah.edu
  - Engineering design services
  - o (Bio)MEMS design and fabrication
  - Advanced package development

## AFFILIATED CHARACTERIZATION LABS

- SMBB Co-located HSC Core Facility www.cores.utah.edu/
  - JEM 1400 TEM (120 keV)
  - FEI Technai T-12 TEM (120 keV), T-20 (200 keV cryo)
  - Olympus FV-1000 Scanning laser confocal sources: 405, 457, 488, 514, 568, 633, 748nm
- Dixon Laser Institute www.physics.utah.edu/laser/
  - o Witec Alpha 300 SNOM, Raman, and Confocal
  - o FEI NovaNano 630 FE-SEM w/ EDS, CL and Nabity EBL
- X-ray CT Lab Michael Czabaj m.czabaj@utah.edu
  - Varian BIR/150/130; GE eXplore Locus SP
- Fast-capture camera o.kingstedt@utah.edu
  - o +10M fps Shimadzu Hypervision HPVX2 camera

- Nanomaterials Lab http://nanomaterials.utah.edu
  - Hitachi S-4800 HR-SEM / Oxford EDS (nuclear materials)
  - o Micrometrics ASAP 2020 Surface Area (BET) Porosity
  - o Shimadzu GCMS-QP2010; UFLC HPLC; UV-3600 UV-Vis-NIR
  - Benchtop powder XRD
- BYU: www.chem.byu.edu/faculty/matthew-r-linford/
  - TOF-SIMS IV
- Materials Science http://characterizationlab.mse.utah.edu
  - Philips X'Pert XRD (also DSC, dilatometer)
  - Hitachi S3000-N SEM w/ EDS & EBSD
  - FT-IR (Varian 3100) & PE Lambda 950 UV/VIS
  - Volatile, non-toxic deposition (ebeam and sputt)
- College of Earth Sciences (Geology & Metallurgy)
  - QEMScan 4300 (erich.petersen@utah.edu)
  - WDS microprobe (http://probelab.utah.edu)
  - ICP-MS (diego.fernandez@utah.edu)
  - Bruker D8 thin film XRD s.guruswamy@utah.edu
- Energy and Geosciences Institute (<a href="http://egi.utah.edu">http://egi.utah.edu</a>)
  - QEMScan EVO 50
  - XRD mineral quantitation
  - Wet laboratories (GeoChem Lab)
- Chemistry Department www.chem.utah.edu/facilities/
  - NMR: Unity-300, Inova-400, and VXR-500
  - Single Xyl XRD; MS: TOF, Quad GC, UPLC, FTIR
  - UV-VIS-NIR, Polarimeter, scintillation, lumi, fluor

# MRSEC AFFILIATED LABS

## nanofab.utah.edu/index/about-us/affiliatedlabs

- Organic spintronics deposition system
- Sagnac Interferometer
- Magnetic Resonance X-band cw-EPR, ENDOR, ELDOR
- (3+3)-Pass Tandem Fabry-Perot Interferometer
- THz Time-Domain Spectrometer
- **UV Time-Resolved Spectroscopy**

## AFFILIATED PROTOTYPE MANUFACTURING LABS

- Mechanical Engineering Shops www.mech.utah.edu
  - 3D printing / rapid prototyping
  - Waterjet machining
  - All traditional machine shop tools
- Interference Lithography photonics.ece.utah.edu
- Center for Biomedical Microfluidics www.mems.utah.edu
  - PDMS and soft lithography
  - o CO<sub>2</sub> laser micromachining
  - Knife plotter
- BioInnovationsGateway (BIG) bioinnovationsgateway.org
- Center for Medical Innovation

http://healthsciences.utah.edu/center-for-medical-innovation/

 USTAR North Innovation Center https://ustar.org/find-us-statewide/ustar-innovation-center